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FIRST NAMED INVENTOR ATTORNEY DOCKET NO. FILING DATE CONFIRMATION NO. APPLICATION NO. 10/736,580 12/17/2003 Tatsuhiko Ema 04329.2677-01 4483 03/23/2006 **EXAMINER** 22852 7590 FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER TADESSE, YEWEBDAR T ART UNIT PAPER NUMBER 901 NEW YORK AVENUE, NW WASHINGTON, DC 20001-4413 1734

DATE MAILED: 03/23/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	——/·
		10/736,580	EMA ET AL.	
C	Office Action Summary	Examiner	Art Unit	
		Yewebdar T. Tadesse	1734	
Th	e MAILING DATE of this communication ap	pears on the cover sheet with the	correspondence address	
Period for Re	ply			
WHICHEN - Extensions after SIX (6 - If NO perior - Failure to re Any reply re	ENED STATUTORY PERIOD FOR REPL /ER IS LONGER, FROM THE MAILING D of time may be available under the provisions of 37 CFR 1.) MONTHS from the mailing date of this communication. If or reply is specified above, the maximum statutory period ephy within the set or extended period for reply will, by statut sectived by the Office later than three months after the mailing ent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATIO 136(a). In no event, however, may a reply be ti will apply and will expire SIX (6) MONTHS from e, cause the application to become ABANDONE	N. mely filed n the mailing date of this communic ED (35 U.S.C. § 133).	
Status				
1)□ Res	ponsive to communication(s) filed on			
·		s action is non-final.		
<u> </u>	ce this application is in condition for allowa		osecution as to the merit	is is
•	ed in accordance with the practice under	•		. .
•	·			
Disposition o	•			
•	Claim(s) <u>17-19</u> is/are pending in the application.			
	4a) Of the above claim(s) is/are withdrawn from consideration.			
·	m(s) is/are allowed.			
	m(s) <u>17 and 18</u> is/are rejected. m(s) <u>19</u> is/are objected to.			
· ·	m(s) <u>rs</u> is/are objected to. m(s) are subject to restriction and/o	or election requirement		
O) Ciai	in(3) are subject to restriction and	or election requirement.		
Application F	Papers			
9)□ The	specification is objected to by the Examin	er.		
10)☐ The	drawing(s) filed on is/are: a)□ acc	cepted or b) □ objected to by the	Examiner.	
Appl	icant may not request that any objection to the	e drawing(s) be held in abeyance. Se	e 37 CFR 1.85(a).	
	acement drawing sheet(s) including the correct	= • •	•	
11)∐ The	oath or declaration is objected to by the E	xaminer. Note the attached Office	e Action or form PTO-152	2
Priority unde	r 35 U.S.C. § 119		•	
12)⊠ Ackr a)⊠ AI	nowledgment is made of a claim for foreigi I b)□ Some * c)□ None of:	n priority under 35 U.S.C. § 119(a)-(d) or (f).	
1.	1. Certified copies of the priority documents have been received.			
2.🛛	2. Certified copies of the priority documents have been received in Application No. 09/961,288.			
3.□	Copies of the certified copies of the price	ority documents have been receiv	ed in this National Stage	;
	application from the International Burea			•
* See ti	he attached detailed Office action for a list	t of the certified copies not receive	ed.	
		·		
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Attachment(s)				·
	eferences Cited (PTO-892)	4) Interview Summary		
	raftsperson's Patent Drawing Review (PTO-948) Disclosure Statement(s) (PTO-1449 or PTO/SB/08	Paper No(s)/Mail D	ate Patent Application (PTO-152)	
)/Mail Date	6) Other:		

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DETAILED ACTION

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claim 17 is rejected under 35 U.S.C. 102(b) as being anticipated by Mitani et al (US 5,896,154). Mitani et al discloses a film-forming apparatus, comprising: a dispenser nozzle (head 1 having nozzles 11-14, see Fig. 7) arranged to face a target substrate (sheet 6) to be processed so as to supply a chemical solution (ink) capable of including a solid component and a solvent to the target substrate(sheet 6); a suction nozzle(8) arranged to face the target substrate (sheet 6) for selectively sucking only a solvent vapor on a liquid film formed on the target substrate by the supply of a chemical solution from the dispenser nozzle (11-14); a first moving section (first portion of moving porous belt 34) for relatively moving the target substrate and the dispenser nozzle(11-14); and a second moving section (second portion of moving porous belt 34) for relatively moving the target substrate (sheet 6) and the suction nozzle(8).
- 3. Claims 17-18 are rejected under 35 U.S.C. 102(b) as being anticipated by Liu (US 6,315,832).

With respect to claim 17, Liu discloses (see Fig 1) a film-forming apparatus, comprising: a dispenser nozzle (46) arranged to face a target substrate (30) to be processed so as to supply a chemical solution that is capable of including a solid

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component and a solvent to the target substrate (30); a suction nozzle (exhaust outlet 44) arranged to face the target substrate for selectively sucking only a solvent vapor (see column 3, lines 1-6) on a liquid film formed on the target substrate (30) by the supply of a chemical solution from the dispenser nozzle (46); a first moving section (first portion of chuck 15) for relatively moving the target substrate and the dispenser nozzle; and a second moving section (second portion of chuck 15) for relatively moving the target substrate (30) and the suction nozzle (46).

As to claim 18, Liu discloses (see Fig 1) a supply nozzle of gas flow (valve E supplying Nitrogen) to a liquid film formed on the target substrate.

Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to

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consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

6. Claim 18 is rejected under 35 U.S.C. 103(a) as being unpatentable over Mitani et al (US 5,896,154) in view of Smith (US 5,020,244).

Mitani et al lacks teaching a supply nozzle of gas flow for supplying a flow of gas to a liquid film formed on said target substrate. Smith discloses (see Fig 1) a housing (24) provided with nozzle (opening 26) supplying a flow of gas (expelling air) to a liquid formed on the substrate sheet. It would have been obvious to one of ordinary skill in the art at the time the invention was made to include a supply nozzle of gas flow in Mitani et al to adequately cure the substrate in the post heating treatment as needed.

Allowable Subject Matter

- 7. Claim 19 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 8. The following is a statement of reasons for the indication of allowable subject matter: prior art of record does not disclose or suggest a film-forming apparatus comprising, among others, wherein the length of the suction port of the suction nozzle in the longitudinal direction is larger than the diameter of the target substrate.

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Response to Arguments

9. Applicant's arguments with respect to claims 17-19 have been considered but are most in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Yewebdar T. Tadesse whose telephone number is (571) 272-1238. The examiner can normally be reached on Monday-Friday 8:00 AM-4: 30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Chris Fiorilla can be reached on (571) 272-1187. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Kemel P-P